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**APPLICANTS**

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**\*\* CONTINUING DATA \*\*\*\*\***

This application is a 371 of PCT/JP03/08671 07/08/2003

**\*\* FOREIGN APPLICATIONS \*\*\*\*\***

JAPAN 2002-204703 07/12/2002

Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no	35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after	STATE OR COUNTRY JAPAN	SHEETS DRAWING 6	TOTAL CLAIMS 29	INDEPENDENT CLAIMS 3
Verified and Acknowledged <i>H. H.</i> Examiner's Signature	Initials <i>H. H.</i>				

**ADDRESS**

25944

**TITLE**

Silicon wafer for epitaxial growth, epitaxial wafer, and its manufacturing method

FILING FEE RECEIVED 1350	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time ) <input type="checkbox"/> 1.18 Fees ( Issue ) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit
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